

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Shang-hyeun Park et al.

Application No.: 10/743,791

Filed: December 24, 2003

For:

FIELD EMISSION DISPLAY AND

METHOD OF MANUFACTURING THE

SAME

Group Art Unit: 2879

Examiner: SIKHA ROY

Confirmation No.: 9820

SECOND REQUEST FOR OFFICIAL FILING RECEIPT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

An Official Filing Receipt has not been received for the above-identified application. It is respectfully requested that the U.S. Patent and Trademark Office forward the Official Filing Receipt to the undersigned.

Respectfully submitted,

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Date: December 07, 2004

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